



LABORATORY GROWN DIAMOND REPORT

September 8, 2025	
IGI Report Number	LG732580052
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL MODIFIED BRILLIANT
Measurements	11.05 x 8.24 x 6.88 mm

GRADING RESULTS

Carat Weight	4.42 CARATS
Color Grade	F
Clarity Grade	VS 1

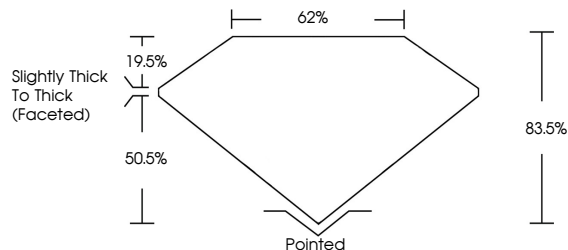
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG732580052

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG732580052
Report verification at lgi.org

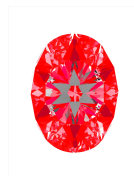
PROPORTIONS



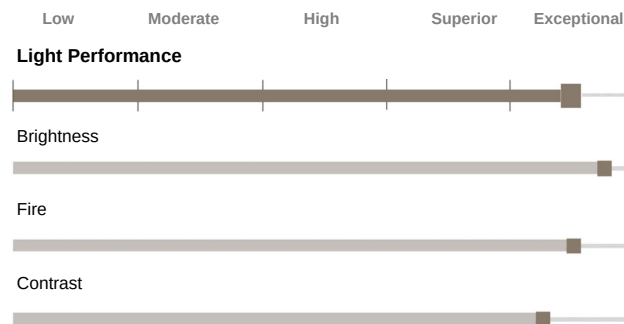
Sample Image Used

LIGHT PERFORMANCE REPORT

Light Performance Grade: Exceptional



Ideal-Scope representation



COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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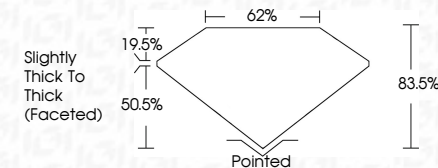
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Fluorescence	NONE
Inscription(s)	(G) LG732580052

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Type IIa



September 6, 2025	4.42 CARATS
IGI Report No. I573250052	F
OVAL MODIFIED BRILLIANT	
11.05 x 8.24 x 4.68 MM	
Carat Weight	
Color Grade	
Clarity Grade	VS 1
Depth	83.5%
Table	62%
Girdle	Slightly thick to thick (Faceted)
Culet	Pointed
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI I573250052
Comments:	
	Chemically Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
	Type Ila